

Form PTO-1449 (modified)		Att'y. Docket No.: ESSR:090US	Serial No.: 10/523,951
List of Patents and Publications for Applicant's INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)		Applicant: Karin SCHERER <i>et al.</i>	
		Filing Date: February 8, 2005	Group: 1794
U.S. Patent Documents <i>See Page 1</i>	Foreign Patent Documents <i>See Page 1</i>	Other Art <i>See Page 1</i>	

U.S. Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Name	Class	Sub Class	Filing Date of App.

Foreign Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Country	Language

Other Art (Including Author, Title, Date Pertinent Pages, Etc.)

Exam. Init.	Ref. Des.	Citation
	C2	Decker <i>et al.</i> , "Thin Film Magnetic Structure with Diffusion Barrier Layer," <i>IBM Technical Bulletin</i> , 22:2865, 1979.

60064944.1

EXAMINER:

DATE CONSIDERED:

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